

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L6	96549	("414").CLAS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/18 09:21
L7	22555	("187").CLAS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/18 09:21
L8	371	(L6 and L7) rail (raise or lift)	US-PGPUB; USPAT; USOCR	AND	ON	2005/10/18 09:21
L10	222	(414/286).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/18 11:23
L12	385	(414/280).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/18 11:23
L14	92	(104/127).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/18 11:45
L15	148	(104/128).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/18 11:45
L16	121	(104/130.04).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/18 11:46
L24	57	(187/249).CCLS.	JPO	OR	OFF	2005/10/18 14:38
L30	111	((187/249,406) or (414/595)).CCLS.	JPO	OR	OFF	2005/10/18 14:38
S2	917	(414/626).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/17 16:15
S5	1202	(414/217).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/17 16:15
S10	343	(414/618).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/17 16:49
S12	241	(414/591).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/17 16:53
S14	96539	("414").CLAS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/17 17:02
S15	22553	("187").CLAS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/17 17:02

S16	8	(S14 and S15) rail (wafer or semiconductor or substrate) (raise or lift)	US-PGPUB; USPAT; USOCR	AND	ON	2005/10/18 09:21
S18	1	(S14 and S15) rail near (L near shaped) (raise or lift)	US-PGPUB; USPAT; USOCR	AND	ON	2005/10/17 17:09
S19	4	(S14 and S15) rail (raise or lift) near (wafer or substrate or (wafer near carrier) or substrate)	US-PGPUB; USPAT; USOCR	AND	ON	2005/10/17 17:10
S20	8	(S14 and S15) rail (raise or lift) (wafer or substrate or (wafer near carrier) or substrate)	US-PGPUB; USPAT; USOCR	AND	ON	2005/10/17 17:11
S23	329	(414/673).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/17 17:14
S24	561	(414/935).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/17 17:14
S25	555	(414/940).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/17 17:14